



Docket No.: P2001,0134

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date indicated below.

By: 

Date: May 25, 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No.	:	10/649,411	Confirmation No.:	5308
Applicant	:	Heike Drummer, et al.		
Filed	:	August 27, 2003		
Title	:	Process for Producing and Removing a Mask Layer		
Art Unit	:	1765.0		
Examiner	:	Kin Chan Chen		
Docket No.	:	P2001,0134		
Customer No.	:	24131		

INFORMATION DISCLOSURE STATEMENT  
UNDER 37 C.F.R. 1.97(C)(2)

Hon. Commissioner for Patents  
Alexandria, VA 22313-1450

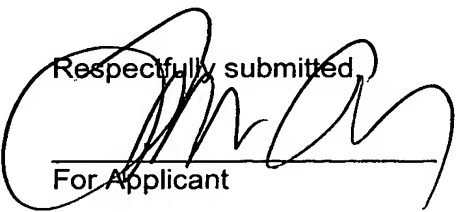
Sir:

In accordance with 37 C.F.R. 1.98 copies of the following patents and/or publications are cited herewith:

Japanese Patent No. JP 07-86393 A (Kiyotoshi, et al.), dated March 31, 1995, and English abstract thereof;

Japanese Office Action, dated April 25, 2006.

Respectfully submitted,

  
For Applicant

Date: May 25, 2006

Lerner Greenberg Sterner LLP  
Post Office Box 2480  
Hollywood, FL 33022-2480  
Tel: (954) 925-1100  
Fax: (954) 925-1101

LAG/rp



FORM PTO-1449 (SUBSTITUTE)  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  INFORMATION DISCLOSURE STATEMENT BY APPLICANT (37 CFR 1.98(b))	Attorney Docket No.: <b>P2001,0134</b>	Applic. No. <b>10/649,411</b>
	Applicant <b>Heike Drummer, et al.</b>	
	Filing Date <b>August 27, 2003</b>	Group Art Unit <b>1765.0</b>

U.S. PATENT DOCUMENTS

EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
	A						
	B						
	C						
	D						
	E						
	F						
	G						
	H						
	I						

FOREIGN PATENT DOCUMENT

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES   NO
	J	JP 07-86393	3/1995	Japan			
	K						
	L						
	M						
	N						

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

	O	
	P	

EXAMINER	DATE CONSIDERED
----------	-----------------

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.